(12) PATENT APPLICATION PUBLICATION

(19) INDIA

(22) Date of filing of Application :17/03/2017

(43) Publication Date : 18/02/2022

## (54) Title of the invention : A FABRICATION PROCESS FOR TUNING MAJOR AND MINOR AXIS OF INLINE FIBER MICRO AIR CAVITY ON DEMAND

(51) International classification	:G02B0006255000, G02B0006020000, B63B0001380000, H01L0023467000, H01L0021480000	<ul> <li>(71)Name of Applicant :</li> <li>1)INDIAN INSTITUTE OF TECHNOLOGY</li> <li>BHUBANESWAR Address of Applicant :Indian Institute of Technology Bhubaneswar, Samantapuri Bhubaneswar, Orissa, India – 751013.</li></ul>
(31) Priority Document No	:NA	(72)Name of Inventor :
(32) Priority Date	:NA	1)Rajan Jha
(33) Name of priority country	:NA	2)Jitendra Narayan Dash
(86) International Application No	:NA	
Filing Date	:NA	
(87) International Publication No	: NA	
(61) Patent of Addition to Application Number:NA		
Filing Date	:NA	
(62) Divisional to Application Number	:NA	
Filing Date	:NA	

(57) Abstract :

The present invention discloses a process for fabricating tunable micro air cavity comprising the steps of involving a Hollow-Core Photonic Crystal Fiber (HCPCF) of predefined length and a single-mode fiber, splicing the SMF with the HCPCF by arc welding based splicer to form the micro air cavity at the junction of the spliced SMF and the HCPCF, tuning size of the micro-cavity by heating the junction of the spliced SMF and the HCPCF using one or more extra welding arcs to change horizontal and vertical lengths of the micro air cavity and providing choice based cavity dimensions depending upon requirement.

No. of Pages : 25 No. of Claims : 13